INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 4, 2026	
IGI Report Number	LG831645671
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.12 - 8.16 X 5.01 MM

GRADING RESULTS

Carat Weight	2.04 CARATS
Color Grade	D
Clarity Grade	VS 1
Cut Grade	IDEAL

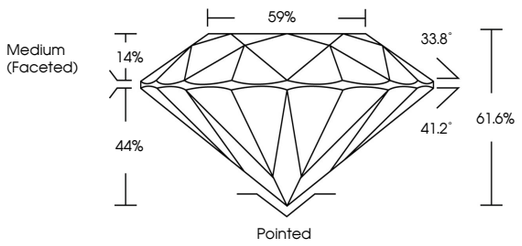
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG831645671

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG831645671
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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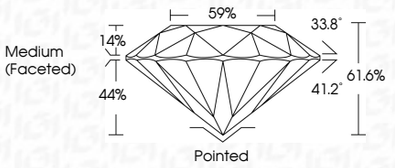
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IGI

September 4, 2026
IGI Report No.LG831645671
ROUND BRILLIANT
8.12 - 8.16 X 5.01 MM
Carat Weight 2.04 CARATS
Color Grade D
Clarity Grade VS 1
Cut Grade IDEAL
Depth 61.6%
Table 59%
Girdle Medium (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG831645671
Comments:
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Type IIa